



PATENT APPLICATION
Q-51885

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Akitaka KIMURA

Appln. No.: 37 C.F.R. §1.53(d) Continuation
of 09/161,981, filed September 29, 1998

Group Art Unit: 2812

Confirmation No.: 8269

Filed: September 29, 1999

Examiner: Mulpuri, S.

For: SEMICONDUCTOR LAYER FORMED BY SELECTIVE DEPOSITION AND METHOD FOR
DEPOSITING SEMICONDUCTOR LAYER

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Commissioner for Patents
Washington, D.C. 20231

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of one (1) month, extending the time for responding to the Office Action of November 20, 2002 from March 20, 2003 to April 20, 2003.

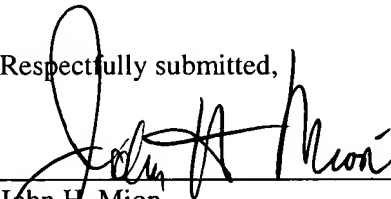
A check for the statutory fee of \$300.00 (second month) is attached. Please charge any additional fees under 37 C.F.R. § 1.16 or § 1.17 necessary to keep this application pending in the Patent and Trademark Office or credit any overpayment to Deposit Account No. 19-4880. A duplicate copy of this sheet is enclosed.

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02 FC:1252

300.00 DP

Respectfully submitted,



John H. Mion
Registration No. 18,879

SUGHRUE MION, PLLC
2100 Pennsylvania Avenue, N.W.
Washington, D.C. 20037-3213
(202) 663-7901

WASHINGTON OFFICE



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Date: April 21, 2003